IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Applicant

Hans Paller

Serial No.

Filed

Title

CONVECTION OVEN AND RELATED AIR FLOW SYSTEM

Docket No.

006593-2020

Art Unit

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Pursuant to 37 C.F.R. §1.56, the Examiner's attention is directed to the references listed on the attached Information Disclosure Citation, copies of which are attached.

It is to be understood that the present submission of art is in no way intended to be a waiver of any arguments or defenses available to the applicant under the rules of the U.S. Patent and Trademark Office and the statutes of the United States.

No fee is required. The Commissioner is authorized to charge any additional fees required by this paper or to credit any overpayment to Deposit Account No. 20-0809.

Respectfully submitted,

Michael J. Nieberding

Reg. No. 39,316

THOMPSON HINE LLP 2000 Courthouse Plaza NE 10 West Second Street Dayton, Ohio 45402-1758 Telephone (937) 443-6892 Facsimile: (937) 443-6635

INFORMA	TION DISCLOSURE CITATION	Docket: 006593-2020		Appln. No.:	Appln. No.:			
		Applic	ant: Hans Paller					
		Filed:		Group:				
	J	J.S. PAT	ENT DOCUMENTS					
Examiner	Document No.	Date	Name	Class	Sub			
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* Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date Considered:

Examiner: